R		pplicant(s)/Patent under eexamination LEPNEV, VLADIMIR I.		
Internal Doc		ocument – DC	cument – DO NOT MAIL	
⊠ APPROVED		☐ DISAPP	☐ DISAPPROVED	
This patent is subject to a Terminal Disclaimer				
Annual difference and have				
Approved/Disapproved by:				
JAB				
	□ APPROV This paten to a Ten Discl	Internal Do APPROVED This patent is subject to a Terminal Disclaimer	Internal Document – DO APPROVED This patent is subject to a Terminal Disclaimer	

U.S. Patent and Trademark Office